

Notice of References Cited	Application/Control No. 10/595,133		Applicant(s)/Patent Under Reexamination STENBERG ET AL.	
	Examiner Harry Liu		Art Unit 3662	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,167,036 A	12-2000	Beven, David Damian Nicholas	370/331
*	B	US-6,282,427 B1	08-2001	Larsson et al.	455/456.2
*	C	US-6,853,847 B2	02-2005	Shioda et al.	455/456.1
*	D	US-7,031,722 B2	04-2006	Naghian, Siama	455/456.1
*	E	US-7,069,023 B2	06-2006	Maanoja et al.	455/456.1
*	F	US-7,155,244 B2	12-2006	Edge, Stephen William	455/502
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.